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PATENT

## EXPRESS MAIL EL669109644US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

T.L. Ritzdorf, et al.

Application No.

09/018,783

Confirmation No.: 1242

Filed

4 February 1998

For

METHOD AND APPARATUS FOR LOW TEMPERATURE

ANNEALING OF METALLIZATION MICRO-STRUCTURES IN

THE PRODUCTION OF A MICROELECTRONIC DEVICE

Examiner

D.M. Collins

Art Unit

2823

Docket No.

29195.8162US

Date

October 1, 2001

Commissioner for Patents Washington, DC 20231

FAX-CUPY RECEIVED

OCT 25 2001

**AMENDMENT** 

TECHNOLOGY CENTER 2800

## Dear Commissioner:

The present Amendment amends both the specification and the claims in the present application. In accordance with 37 C.F.R. § 1.121, enclosed herewith is an Appendix which has been marked to show the changes made by amendment.

## IN THE SPECIFICATION:

Please amend the paragraph appearing at page 12, lines 15-22 to read as follows: